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PATENT APPLICATION

18/amdt B
6/10/03
C.D.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application)

Applicant: John M. Garrett)

Serial No. 09/782,618)

Filed: February 13, 2001)

For: SEMICONDUCTOR)
JUNCTION PROFILE)
AND METHOD FOR THE)
PRODUCTION THEREOF)

Art Unit: 2814)

Examiner: Wille, Douglas A.)

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

May 23, 2003
Date
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Ans B R
Registration No. 43,874

AMENDMENT C

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed December 23, 2002, and in further response to the Advisory Action mailed April 14, 2003, please amend the application as follows: